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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chen et al.

Serial No: 10/643,520

Filed: 08/18/2003

For: **HEMI-SPHERICAL GRAIN SILICON  
ENHANCEMENT**

Docket Number: 2002-0864.00/US

Paper No.:

Art Unit: 2825

Examiner: Everhart, Caridad

*Please  
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CME  
1/24/05*

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Certificate of Mailing (37 C.F.R. §1.8)

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Dear Commissioner:

**REPLY AND AMENDMENT UNDER 37 CFR §1.111**

This paper is in response to the outstanding Office Action, dated 09/29/2004.